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Launcher Performance and Thermal Capability of the DIII–D ECH System

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Abstract. The temperatures of components of DIII–D ECH launchers were observed during 2003 tokamak operation. The injected power was typically 500–700 kW and the pulse length was typically 2 s. Plasma shots were performed at intervals of about 17 min from 9 a.m. to 5 p.m. The temperatures of a movable mirror, a fixed mirror and a launcher reached an equilibrium after about six hours of repetitive pulsing. The saturation temperature depends to some extent on the plasma stored energy. However, even in high β plasma, the temperatures plateaued at acceptable values.

I. INTRODUCTION

A 110 GHz electron cyclotron heating (ECH) and current drive system has been developed on the DIII–D tokamak since 1997. The high power (up to 1 MW/gyrotron) and long pulse (up to 10 s) rf is generated by gyrotrons and delivered by wave guides connected to launchers in the tokamak vacuum vessel. The launchers are designed for radiative cooling for simplicity and to avoid potential water leakage inside the tokamak vacuum vessel. The design requires that the temperatures of launcher components be monitored to prevent the melting of the rf reflecting surfaces of the mirrors. The surface temperature could be increased abnormally by surface arcing, plasma disruption or radiation from the plasma. In this paper, the thermal performance of mirrors and wave guides during the 2003 DIII–D campaign is discussed.

The ECH system [1] consists of six 110 GHz gyrotrons and three launchers which include two waveguides each (Fig. 1). Three of the gyrotrons were manufactured by Communications and Power Industries (CPI) [2] and the others were made by Gycom [3]. The CPI gyrotrons have chemical vapor deposition (CVD) diamond output windows which support 1 MW, 10 s operation for Gaussian output rf beams [4]. The Gycom gyrotrons have boron nitride windows, which limit the pulse lengths for these tubes to 2 s with 750 kW rf generation. The rf is transported by ~100 m of 31.75 mm diameter evacuated corrugated waveguide carrying the HE1,1 mode. Each wave guide has a pair of grooved polarizers which can produce arbitrary elliptical polarization of the wave.

II. ECH LAUNCHERS

The DIII–D ECH system uses three launcher assemblies, each of which can inject rf power from two gyrotrons. Poloidal and toroidal steering is provided using movable mirrors of different designs to direct the rf beams. Eddy current induced forces arising during disruptions are a concern for the actuator assemblies on the movable mirrors, which have limited ability to react the forces. Therefore, mirror designs which minimize the volume of high conductivity copper while maintaining low resistivity reflecting surfaces have been developed. The mirrors are radiatively cooled, leading to a requirement to evaluate the thermal performance of the three different mirror designs for the expected maximum rf energy, 800 kW, 10 s.

One mirror, the “GA mirror” is made from Glidcop, with a thick center, providing thermal inertia, and thin periphery, reducing disruption forces. This mirror is grooved and blackened on the back to increase radiative cooling. This mirror design and simulation analysis, using the finite element code COSMOS [5], is reported in Ref. [6]. For this mirror, the experimental temperature increase was in good agreement with the simulation [7].

A second mirror is made of graphite with a molybdenum reflecting surface brazed to it [Fig. 2(a)]. This design, designated “PPPL99” significantly reduces eddy currents and easily withstands the disruption forces. However, the surface temperature is higher than for the GA mirror because of the higher resistivity of molybdenum. Therefore, the pulse length is limited to 5 s.

The third mirror design is called the “PPPL01” mirror, which has a sandwich structure of Glidcop and stainless steel [Fig. 2(b)]. The reflecting surface on this mirror is a thin Glidcop layer supported by the sandwich. This design has the best overall performance of the three and meets the power, pulse length and duty cycle requirements.

The launchers are monitored by a set of diagnostics. Each dual launcher has ten resistance temperature devices (RTDs), two Langmuir probes and two video camera ports. Four of the RTDs are attached to the back surfaces of the movable mirrors (two RTDs each mirror). The other four RTDs are mounted to the back surfaces of the fixed mirrors and one RTD is on each launcher waveguide. Fiberoptically coupled video is used to detect launcher arcing and this video is recorded for each launcher waveguide, providing redundant arc detection.

In the DIII–D 2003 campaign, the “PPPL99” and “PPPL01” mirrors were used.

Fig. 1. Launcher assembly. Each launcher has two wave guides. The RTDs are located on the back surfaces of the fixed mirrors and movable mirrors. The waveguide temperature is also observed near the launching end.
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Fig. 2. Schematic view of the PPPL99 mirror and PPPL01 mirrors. The surface of the PPPL99 mirror is molybdenum and the PPPL01 is Glidcop. Both mirrors have two RTDs attached to their back surfaces.

III. PRELIMINARY EXPERIMENT

To check the RTD system, a simple experiment we performed on the test stand as described in Fig. 3. Additional RTDs were prepared at positions α, β and γ indicated in the figure. RTD#1 and RTD#2 are the normally installed RTDs which remained in place following the tests. An ice cube was held against the mirror surface for 60 s with a thin plastic barrier sheet. The response of all the RTDs was then measured.

Fig. 3. Schematic view of RTD system check experiment. The ice was held against the surface for 60 s with a thin plastic protective barrier. Diagnostic RTDs were attached at the positions indicated by α, β and γ. RTD#1 and RTD#2 are the regular RTDs which were used during the plasma experiments.

Fig. 4. The time evolution of the measured temperatures for the ice experiment for (a), the PPPL99 movable mirror and (b), the PPPL01 movable mirror.

During plasma operations the time interval between plasma shots is more than 10 min. Therefore, for both designs, the entire mirror comes to one temperature between shots. The results show that RTD#1 and #2, which are located on the back surface, are useful for monitoring the base temperature increases of the mirror body, but will not accurately follow the surface temperatures for 6 second tokamak pulses.

IV. PLASMA EXPERIMENTS

Fig. 5 shows the typical temperature increases for the PPPL99, the PPPL01, and one of the fixed Glidcop focusing mirrors on the PPPL01 launcher plus the launcher waveguides fed by the Gycom-2 gyrotron also on the PPPL01 launcher during one day of tokamak operation. All measured temperatures are about 30°C at the beginning of the plasma experiments. These temperatures are somewhat higher than the actual temperature because the temperatures are measured by two wire RTDs, which do not provide compensation for lead resistance, nevertheless, the relative temperature increases are accurate. The data were acquired every 200 ms for 10 min after the shot. In some cases, straight lines were used to connect the data for different shots. The time between plasma shots this day typically was about 17 min and the typical rf pulse lengths were 2 s. therefore, the duty cycle was about 0.2%. The power injected into the tokamak for the PPPL99
movable mirror was about 700 kW and for the PPPL01 movable and fixed mirrors was about 500 kW. The waveguide power was about 700 kW.

The spikes in the plots correspond to plasma shots with rf injection. The heights of the spikes show the peak measured temperatures, which are lower than the peak mirror surface temperatures. Despite the time response issues addressed earlier, the peak temperature of the PPPL99 mirror with molybdenum surface was 2–3 times higher than the PPPL01 mirror with Glidcop surface. The surface temperature is caused by ohmic loss and is proportional to the electrical resistivity of the surface. The resistivity of molybdenum is 12.7 μΩ, which is 3.5 times higher than Glidcop. The temperature decrease of the PPPL99 mirror following the pulse is faster than PPPL01 mirror. The volume thermal capacity of graphite is about 1.6–2.2 J K⁻¹ cm⁻³, which is 1.6–2.2 times lower than Glidcop and stainless steel. Therefore, for the same energy applied to the mirror surfaces, the substrate temperature will be higher for the graphite than for the copper/stainless steel with concomitant 7–23 times higher radiative cooling rate, under the assumption of T⁴ dependence of the radiation.

The temperature increase of the fixed Glidcop mirror is lower than for either of the movable mirrors. Not only is the initial power deposition low for this mirror, but also there is substantial energy conduction to its supports compared with the movable mirrors, which are primarily cooled by radiation. The waveguide temperature was practically not increased during the pulse, showing that there was no extraordinary rf heating at the end of the waveguide.

The long term temperature increase plateaued after about 6 h of operation at a measured temperature about 50°C higher than the starting temperature for both the PPPL99 and PPPL01 mirrors, well within the values required to avoid mirror surface damage. The fixed mirror and waveguide had even smaller temperature increases than the movable mirrors. Under normal operation, temperature ratcheting is not a concern for either mirror design.

In addition to the rf induced heating of the mirrors, radiation from the plasma also heats the mirrors and surrounding structure. This is examined in Fig. 6. For the PPPL01 movable mirror. The plateau temperature in the high β plasma case with higher P_{inj} and P_{rad} (β_N=3–4) was about 60°C, which was 30°C higher than the low beta case (β_N=1–2). The high β case was for one of the highest β operational days for DIII–D and included several plasma disruption shots. Nevertheless, the temperature at the end of the day was well within acceptable limits.

For normal DIII–D shots, about 40% of the mirror temperature increase is not related to ECH injection at all, but arises from heating of the launcher and surroundings by plasma radiation. This is indicated in Fig. 7, in which 500 kW injection at 1.0–1.5 s pulse length is compared with no rf injection for the same series of plasma shots. The plasma normalized β was about 1. The equilibrium increases of launcher mirror temperatures with and without ECH were 35°C and 15°C respectively.

By calculating the energy delivered to the mirrors by the ECH, the energy input from the plasma can be estimated. The input energy of ECH is 500 kW × 0.002 × 1 s/115 cm² = 8.7 J/cm². Here, the factor 0.002 is the rf absorption of the mirror surface and 115 cm² is the surface area of the PPPL01 movable mirror. Therefore, the injected energy from the plasma is roughly calculated as 8.7 J/cm² × 15°C/20°C = 6.5 J/cm². The plasma auxiliary heating energy was approximately 5 MJ for NBI and 3.6 MJ for ECH for these DIII–D shots. Therefore, the energy input to the mirror surface was 1.0 J/cm²/MJ of energy input to the plasma. This is of the same order as found in the previous study (0.36 J/cm² [6]).

V. Conclusion

The temperatures of DIII–D ECH launcher components were observed during 2003 tokamak operation. The temperature was monitored through a whole day (typical plasma shot interval 17 min, rf power was 500 kW for PPPL01 and 700 kW for PPPL99, pulse length of rf was 2 s). All the temperatures have plateaued by about 15:00. The temperatures of two types of movable mirror (PPPL99 and PPPL01) were increased by about 50°C above the beginning of the plasma operation. This was a small temperature increase from the viewpoint of the avoidance of the melting of the mirror surface.
A certain amount of mirror heating by plasma radiation was observed. However, the combination of 2 s ECH and one of the highest $\beta$ operational days only resulted in a 60°C temperature increase. This was not a problematic temperature increase. The roughly estimated energy input from plasma to the movable mirror surface is 1.01 J/cm$^2$/MJ of energy input to plasma.

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REFERENCES


[2] Communications and Power Industries, Palo Alto CA USA

[3] Gycom, Nizhny Novgorod, Russia


[5] COSMOS, A Finite Element Analysis Code, Structural Research, Santa Monica, California, USA.
